

VIA FACSIMILE NO. (703) 872-9310

PATENT
MIC04 P-106

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner : George A. Goudreau
Group : 1763
Confirmation No. : 4253
Applicant : Imad Mahawili, PhD
Serial No. : 09/488,309
Filed : January 20, 2000
For : REACTOR WITH REMOTE PLASMA SYSTEM AND
METHOD OF PROCESSING A SEMICONDUCTOR
SUBSTRATE

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OFFICIAL

Commissioner for Patents
P.O. Box 1450
Alexandria VA 22313-1450

Date of this Paper: December 17, 2003.

Dear Sir:

PETITION AND FEE FOR
EXTENSION OF TIME (37 C.F.R. 1.136(a))

1. This is a petition for an extension of time to respond to the Office Action mailed July 17, 2003, for a period of two months.

2. Applicant is:

a small entity

verified statement attached
verified statement filed

☒ other than small entity

3.	Extension (months)	Fee for other than small entity	Fee for small entity
	one month	\$110.00	\$55.00
	<input checked="" type="checkbox"/> two months	\$420.00	\$210.00
	three months	\$950.00	\$475.00

4. An amendment:

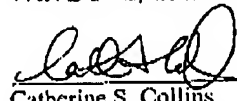
☒ is filed herewith

has been filed

5. Fee Payment:

☒ Please charge the amount of \$420 and any additional fees required or credit any excess fee paid to Deposit Account No. 22-0190. A duplicate of this Petition is attached.

VAN DYKE, GARDNER, LINN & BURKHART, LLP



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